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SERIAL NUMBER 10/501,155	FILING or 371(c) DATE 07/13/2004 RULE	CLASS 105	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. SON-2563		
APPLICANTS Koichiro Saga, Kanagawa, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/00938 01/30/2003 JLW ** FOREIGN APPLICATIONS ***** JAPAN 2002-021097 01/30/2002 JLW ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <i>[Signature]</i> Examiner's Signature		<input type="checkbox"/> Met after Allowance <i>JLW</i> Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 7	TOTAL CLAIMS 41	INDEPENDENT CLAIMS 13
ADDRESS RADER FISHMAN & GRAUER PLLC LION BUILDING 1233 20TH STREET N.W., SUITE 501 WASHINGTON, DC 20036 UNITED STATES						
TITLE Surface treatment method, semiconductor device, method of fabricating semiconductor device, and treatment apparatus						
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